



**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q80433

Makoto MOMOTA, et al.

Appln. No.: 10/802,808

Group Art Unit: 1752

Confirmation No.: 5096

Examiner: Yvette C. Thornton

Filed: March 18, 2004

For: POSITIVE RESIST COMPOSITION AND PATTERN FORMATION METHOD USING  
THE SAME

**AMENDMENT UNDER 37 C.F.R. § 1.111**

**MAIL STOP AMENDMENT**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

This is in response to the Office Action dated June 7, 2005. A Petition and payment for a one-month extension of time are attached, making this Amendment due on or before October 7, 2005.

Please amend the above-identified application as follows on the accompanying pages.

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